

EAST Search History

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	761	604/8.ccls.	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	ON	2006/06/01 14:53
S2	142	kawamura-akio.in.	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	ON	2006/06/01 14:24
S3	4	S2 and (dialysis)	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	ON	2006/06/01 14:26
S4	1	"6524273".pn.	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	ON	2006/06/01 14:44
S5	7	S2 and (needle)	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	ON	2006/06/01 14:26
S6	1	"4822341".pn.	US-PGPUB; USPAT; USOCR; EPO; JPO	OR	ON	2006/06/01 14:44
S7	56	("3765032" "3826257" "4015601" "4092983" "4108173" "4164221" "4187390" "4350157" "4405319" "4496349" "4512761" "4578063" "4596350" "4639247" "4648391" "4654033").PN. OR ("4822341"). URPN.	US-PGPUB; USPAT; USOCR	OR	OFF	2006/06/01 14:48

Assignment Data Not Available

For Application Number: 10725508

Search Results as of: 6/1/2006 2:08:35 P.M.

If you have any comments or questions concerning the data displayed, contact OPR / Assignments at 571-272-3350
Web interface last modified: Mar 14, 2006 v.1.9

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Date: 6/1/2006
Time: 12:43:42

PALM INTRANET

Inventor Name Search Result

Your Search was:

Last Name = KAWAMURA

First Name = AKIO

Application#	Patent#	Status	Date Filed	Title	Inventor Name
<u>06661469</u>	Not Issued	166	10/16/1984	METHOD OF FABRICATING FROZEN FINE LIVER PIECES FOR ARTIFICIAL LIVER, APPARATUS FOR FREEZING THE SAME, AND FREEZING VESSEL	KAWAMURA, AKIO
<u>06847677</u>	Not Issued	166	04/03/1986	METHOD FOR FORMING A POLYCRYSTALLINE SILICON THIN FILM	KAWAMURA, AKIO
<u>07196816</u>	Not Issued	161	05/17/1988	METHOD FOR FORMING A POLYCRYSTALLINE SILICON THIN FILM	KAWAMURA, AKIO
<u>07245925</u>	4883452	250	09/16/1988	METHOD OF FABRICATING FROZEN FINE LIVER PIECES FOR ARTIFICIAL LIVER, APPARATUS FOR FREEZING THE SAME, AND FREEZING VESSEL	KAWAMURA, AKIO
<u>07413720</u>	Not Issued	166	09/28/1989	ISOLATOR FOR ELECTRICALLY ISOLATING SEMICONDUCTOR DEVICE IN AN INTEGRATED CIRCUIT	KAWAMURA, AKIO
<u>07653074</u>	5096848	150	02/11/1991	METHOD FOR FORMING SEMICONDUCTOR DEVICE ISOLATING REGIONS	KAWAMURA, AKIO
<u>07673192</u>	5208690	150	03/21/1991	LIQUID CRYSTAL DISPLAY HAVING A PLURALITY OF PIXELS WITH SWITCHING TRANSISTORS	KAWAMURA, AKIO
<u>07760131</u>	5173444	150	09/16/1991	METHOD FOR FORMING A SEMICONDUCTOR DEVICE ISOLATION REGION	KAWAMURA, AKIO
<u>07841773</u>	5189501	150	03/02/1992	ISOLATOR FOR	KAWAMURA, AKIO

				ELECTRICALLY ISOLATING SEMICONDUCTOR DEVICES IN AN INTEGRATED CIRCUIT	
<u>07933820</u>	<u>5266508</u>	150	08/24/1992	PROCESS FOR MANUFACTURING SEMICONDUCTOR DEVICE	KAWAMURA, AKIO
<u>07946331</u>	<u>5314624</u>	250	11/10/1992	PROCESS FOR FILTERING PLASMA AND REGENERATING A SECONDARY FILTER THEREFOR	KAWAMURA, AKIO
<u>07953866</u>	Not Issued	164	09/30/1992	A LIQUID CRYSTAL DISPLAY HAVING A PLURALITY OF PIXELS WITH SWITCHING TRANSISTORS	KAWAMURA, AKIO
<u>08036621</u>	<u>5278082</u>	150	03/24/1993	METHOD FOR ELECTRICALLY CONNECTING AN ELECTRODE AND IMPURITY-DIFFUSED LAYER FORMED ON A SEMICONDUCTOR SUBSTRATE	KAWAMURA, AKIO
<u>08103250</u>	<u>5362670</u>	150	08/09/1993	SEMICONDUCTOR DEVICE PRODUCING METHOD REQUIRING ONLY TWO MASKS FOR COMPLETION OF ELEMENT ISOLATION REGIONS AND P- AND N-WELLS	KAWAMURA, AKIO
<u>08202262</u>	<u>5460715</u>	250	02/25/1994	APPARATUS FOR FILTERING PLASMA	KAWAMURA, AKIO
<u>08302774</u>	<u>5516431</u>	150	09/19/1994	METHOD OF WASHING SECONDARY FILTER IN PROCESS FOR FILTERING PLASMA	KAWAMURA, AKIO
<u>08333293</u>	<u>5526304</u>	150	11/01/1994	A SEMICONDUCTOR MEMORY DEVICE INCLUDING THIN-FILM LOAD TRANSISTORS	KAWAMURA, AKIO
<u>08424058</u>	<u>5629744</u>	150	04/19/1995	ACTIVE MATRIX DISPLAY DEVICE AND TIMING GENERATOR	KAWAMURA, AKIO
<u>08604746</u>	<u>5859626</u>	150	02/23/1996	DISPLAY CIRCUIT WHICH AUTOMATICALLY DECIPHERS DIFFERENT	KAWAMURA, AKIO

				VIDEO FORMATS AND OPTIMIZES THE HORIZONTAL AND VERTICAL CENTERING OF THE IMAGE ON THE DISPLAY	
<u>08684468</u>	<u>5767830</u>	150	07/19/1996	ACTIVE MATRIX DISPLAY DEVICE AND TIMING GENERATOR WITH THINNING CIRCUIT	KAWAMURA, AKIO
<u>08694067</u>	<u>5734185</u>	150	08/08/1996	"MOS TRANSISTOR AND FABRICATION PROCESS THEREFOR"	KAWAMURA, AKIO
<u>08871680</u>	<u>5795803</u>	150	06/09/1997	METHOD FOR MANUFACTURING A SEMICONDUCTOR DEVICE	KAWAMURA, AKIO
<u>09228238</u>	Not Issued	168	01/11/1999	DISPLAY DEVICE	KAWAMURA, AKIO
<u>09307716</u>	<u>6231541</u>	150	05/10/1999	NO-NEEDLE BLOOD ACCESS DEVICE FOR HEMODIALYSIS AND NO-NEEDLE CONNECTING CANNULA ASSEMBLY	KAWAMURA, AKIO
<u>09372091</u>	Not Issued	161	08/11/1999	MULTIPLE TRENCH ISOLATION INTEGRATED CIRCUIT	KAWAMURA, AKIO
<u>09429485</u>	<u>6441456</u>	150	10/29/1999	SEMICONDUCTOR DEVICE AND A PROCESS FOR MANUFACTURING THE SAME	KAWAMURA, AKIO
<u>09443007</u>	<u>6495874</u>	150	11/18/1999	SEMICONDUCTOR DEVICE AND PRODUCTION PROCESS THEREOF	KAWAMURA, AKIO
<u>09851326</u>	<u>6524273</u>	150	05/09/2001	NO-NEEDLE BLOOD ACCESS DEVICE FOR HEMODIALYSIS	KAWAMURA, AKIO
<u>10725508</u>	Not Issued	30	12/03/2003	No-needle blood access device for hemodialysis	KAWAMURA, AKIO

Inventor Search Completed: No Records to Display.

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